Accepted Manuscript

Title: An Automatic Algorithm for Determination of the Nanoparticles from TEM Images Using Circular Hough Transform

Authors: Mohsen Mirzaei, Hossein Khodabakhshi Rafsanjani

PII: S0968-4328(17)30043-4

DOI: http://dx.doi.org/doi:10.1016/j.micron.2017.02.008

Reference: JMIC 2398

To appear in: *Micron*

Received date: 1-2-2017 Revised date: 24-2-2017 Accepted date: 24-2-2017

Please cite this article as: Mirzaei, Mohsen, Rafsanjani, Hossein Khodabakhshi, An Automatic Algorithm for Determination of the Nanoparticles from TEM Images Using Circular Hough Transform.Micron http://dx.doi.org/10.1016/j.micron.2017.02.008

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ACCEPTED MANUSCRIPT

An Automatic Algorithm for Determination of the Nanoparticles from TEM Images Using Circular Hough Transform

Mohsen mirzaei^{1*}, Hossein Khodabakhshi Rafsanjani²

Highlights

- Automated measurement of the number and the average primary diameter of the nano particles from TEM images
- This method is based on the modified version of the hough transform with pre-processing modifications on TEM images.
- The method has been tested on several TEM images with different complexity in the images.
- It has less than 5% difference over 11 different TEM images, relative to manual sizing

• Abstract

Nanoparticles have a wide range of applications in science and technology, and the size distribution of nanoparticles is one of the most important statistical properties. Transmission electron microscopy (TEM) or X-ray diffraction is commonly used for the characterization and measuring particle size distributions, but manual analysis of the micrographs is extremely labor-intensive. Here, we have developed an image processing algorithm for measuring

¹Department of Engineering, Vali-e-Asr University of Rafsanjan, Rafsanjan, Iran

²Department of Electrical Engineering, Sahand University of Technology, Tabriz, Iran

^{*}Correspondence author: Fax: +98 34 3131 2186, Email: m.mirzaei@vru.ac.ir

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